



IPW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takunori IKI et al.

Group Art Unit: 2812

Application No.: 10/633,682

Examiner: Unknown

Filed: August 5, 2003

Docket No.: 116507

For: SYSTEM AND METHOD OF MANUFACTURING A SUBSTRATE DEVICE

AMENDMENT AND RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the January 12, 2005 Restriction Requirement, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.